EAST Search History

Ref#	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	1	(FEOL resistor substrate trench isolation silicide).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/03/17 09:12
L3	31	(resistor substrate trench isolation silicide).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/03/17 09:12
L4	3	(resistor substrate trench isolation silicide patterned dielectric). clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/03/17 09:12
L5	1	(resistor substrate trench isolation silicide patterned dielectric CMOS).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/03/17 09:13
S1	2	"20060267136"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/31 09:16
S2	20	"6295721"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/31 09:16
S3	2	"20030209777"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/31 10:36

S4	1071	metal adj resistor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/31 10:37
S 5	431	semiconductor and S4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/31 10:37
S6	361	semiconductor and S4	US-PGPUB; USPAT	OR	ON	2007/05/31 10:37
S7	180	(MOS cmos nmos pmos) and S6	US-PGPUB; USPAT	OR	ON	2007/06/11 08:31
S8	17	"5038184"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/02 15:27
S9	28	(Kim near Dae-Hyun). in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/02 15:31
S10	2	i"20030047782"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/02 15:32
S11	178	(Hasegawa adj Hisashi).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/02 15:33
S12	4	S11 and (metal adj resistor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/02 15:33
S13	5523	257/347	US-PGPUB; USPAT	OR	ON	2007/06/11 08:32
S14	312	438/235	US-PGPUB; USPAT	OR	ON	2007/06/11 08:32

S15	3137	438/238	US-PGPUB; USPAT	OR	ON	2007/06/11 08:32
S16	24	S15 and metal near resistor	US-PGPUB; USPAT	OR	ON	2007/06/11 08:33
S17	80	S15 and etch adj stop and resistor	US-PGPUB; USPAT	OR	ON	2007/06/11 08:33
S19	2	"20060027878"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/26 00:03

^{3/17/2008 9:13:57} AM

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